

Docket No. 278426US0PCT

IN RE APPLICATION OF: Mitsugu ABE, et al.

SERIAL NO: 10/549,294

FILED: September 16, 2005

FOR: MATERIAL FOR PURIFICATION OF SEMICONDUCTOR POLISHING SLURRY, MODULE FOR PURIFICATION OF SEMICONDUCTOR POLISHING SLURRY AND PROCESS FOR PRODUCING SEMICONDUCTOR POLISHING SLURRY

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
 Additional documents filed herewith: Request for Extension of Time (two months); Copy of Preliminary Amendment Filed October 25, 2005; with Date-Stamped Filing Receipt

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	17	MINUS	28	0	x \$50 =	\$0.00
INDEPENDENT	4	MINUS	3	1	x \$200 =	\$200.00
APPLICATION SIZE		MINUS	100	0 (each addtl. 50 sheets)	x \$250 =	\$0.00
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS				+ \$360 =	\$0.00	
TOTAL OF ABOVE CALCULATIONS					\$200.00	
<input type="checkbox"/> Reduction by 50% for filing by Small Entity					\$0.00	
					TOTAL	\$200.00

- A check in the amount of \$0.00 is attached.
 Online credit card payment is being made to cover the fees in the amount of \$650.00
 Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030.
 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030.

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